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## BIB DATA SHEET

CONFIRMATION NO. 8414

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/645,665	08/22/2003	427	2821	2328-062		
<b>APPLICANTS</b> Raj Dhindsa, San Jose, CA; S.M. Reza Sadjadi, Saratoga, CA; Felix Kozakevich, Sunnyvale, CA; Dave Trussell, Fremont, CA; Lumin Li, Fremont, CA; Eric Lenz, Pleasanton, CA; Camelia Rusu, Fremont, CA; Mukund Srinivasan, Fremont, CA; Aaron Eppler, Fremont, CA; Jim Tietz, Fremont, CA; Jeffrey Marks, San Jose, CA;						
<b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 11/19/2003						
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /TUNG X LE/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance TXL Initials	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWINGS</b> 3	<b>TOTAL CLAIMS</b> 45 64	<b>INDEPENDENT CLAIMS</b> 6
<b>ADDRESS</b> LOWE HAUPTMAN HAM & BERNER, LLP 1700 DIAGONAL ROAD SUITE 300 ALEXANDRIA, VA 22314 UNITED STATES <div style="text-align: right;">TXL 3/21/2008</div>						
<b>TITLE</b> Multiple frequency plasma etch reactor processor method and apparatus						
<b>FILING FEE RECEIVED</b> 2470	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			